

PATENT
 Any. Dkt. No. AMAT/5618/DSM/LOW K/JW

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:
Nguyen, et al.**

Serial No.: 09/912,103

Confirmation No.: 4476

Filed: July 23, 2001

**For: Selective Etching of
Organosilicate Films Over
Silicon Oxide Stop Etch Layers**

www.pearsoned.com

Group Art Unit: 2823

Examiner: Khiem D. Nguyen

MAIL STOP
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

**CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-746-9179 to the attention of the named Examiner, on the date below.

10/2/2003
Date

Robt D. Edwards
Signature

RESPONSE TO OFFICE ACTION DATED JULY 2, 2003

In response to the Office Action dated July 2, 2003, having a shortened statutory period for response set to expire on October 2, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5619/BTP, the fee of \$72.00 for four additional dependent claims, and any other fees, including extension of time fees, required to make this Response timely and acceptable to the Office.

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FACSIMILE COVER SHEET

DATE: August 5, 2004
FILE NO: AMAT/5619/DSM/LOW K/JW
TO: Examiner Khiem D. Nguyen
FAX NO: 571-273-1865
PHONE NO: 571-272-1865
COMPANY: USPTO
FROM: Keith M. Tackett
PAGE(S) with cover: 11

ORIGINAL TO FOLLOW? ☐ YES ☒ NO

MESSAGE: Attached are copies of the Response to Office Action dated July 2, 2003; Facsimile Cover Sheet; and Confirmation Facsimile Transmittal filed on October 2, 2003, which was faxed to the designated fax number 703-746-9179 from the Office Action dated February 14, 2003.

RESPONSE TO OFFICE ACTION DATED JULY 2, 2003

TITLE: SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER
SILICON OXIDE STOP ETCH LAYERS
U.S. SERIAL NO.: 09/912,103
FILING DATE: JULY 23, 2001
INVENTOR: NGUYEN, ET AL.
EXAMINER: KHIEM D. NGUYEN
GROUP ART UNIT: 2823
CONFIRMATION NO.: 4476

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